

*John Belmont Jr.*  
PATENT APPLICATION  
06/028  
12/09/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Tomoo MURAKAMI

Divisional of Appln. No. 09/120,204  
Filed: July 22, 1998

Group Art Unit: 3729  
Examiner: L. Young

Appln. No.: Not yet assigned  
Filed: January 16, 2002

Group Art Unit: not yet assigned

For: METHOD OF MOUNTING A SEMICONDUCTOR DEVICE TO A SUBSTRATE AND  
A MOUNTED STRUCTURE

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Prior to examination, please amend the above-identified application as follows:

**IN THE SPECIFICATION:**

Amend the specification by inserting before the first line the sentence:

*AI*  
This is a divisional of Application No. 09/120,204 filed July 22, 1998; the disclosure of  
which is incorporated herein by reference.

Page 1, fourth paragraph, which bridges to page 2, please delete and insert the  
following new paragraph:

Referring to Fig. 1, an insulating resin layer 2 made of a material such as rubber having

*AD*  
elastic recovery force is formed on a substrate 1. Further, a mounting pad 3 is formed on the  
insulating resin layer 2 by means of sputtering or vapor deposition. A sealing resin 5 is coated to